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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: 2812
Examiner: Stanetta D. Isaac

In Re PATENT APPLICATION of:

Applicant(s): Jun KANAMORI

Serial No.: 10/634,851

Filing Date: August 6, 2003

For: SEMICONDUCTOR DEVICE
FABRICATION METHOD USING
OXYGEN ION IMPLANTATION

Atty. Dkt.: MAE 292

AMENDMENT

February 24, 2005

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Examiner's Action mailed on August 25, 2004, the period for response to which is extended by a Petition for a Three-month Extension of Time filed herewith, please amend the above-identified application as follows:

FEE ENCLOSED: \$1,020.00
Please charge any further
fee to our Deposit Account
No. 18-0002